In re Applica	tion of:)
Serial No.:	: 10/809,906)) Examiner: McDonald, Shantese L.) Art Unit: 3723
Filed:	March 26, 2004)
For: A Technique For Process-Qualifying A Semiconductor Manufacturing Tool Using Metrology Data)) _)
P.O. Box 14	er for Patents	

AMENDMENT AND RESPONSE TO OFFICE ACTION

Sir:

In response to the Final Office Action mailed October 6, 2006, Applicants respectfully request the Examiner to enter the following amendments and consider the following remarks:

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

on <u>April 5, 2007</u>			
Date of Deposit			
Michelle Begay			
Name of Person Mailing Correspondence			
Michelle Boa	April 5, 2007		
Signature	Date		

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